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GEMOLOGICAL  
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LABORATORY GROWN DIAMOND REPORT

August 28, 2024

IGI Report Number

LG649418483

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

EMERALD CUT

Measurements

9.53 X 6.92 X 4.53 MM

GRADING RESULTS

Carat Weight

3.04 CARATS

Color Grade

D

Clarity Grade

VS 1

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT


Symmetry

EXCELLENT

Fluorescence


NONE

Inscription(s)

 LG649418483

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

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
Symmetry

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Fluorescence

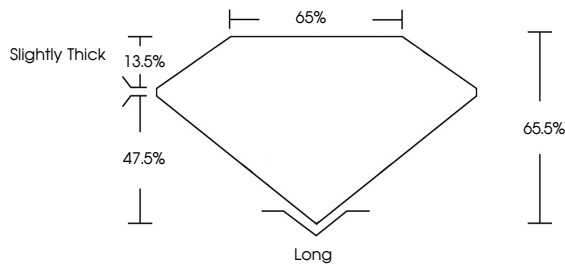
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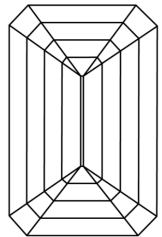
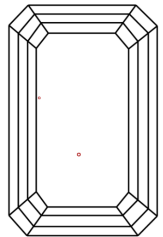
PROPORTIONS





Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light



CLARITY

IF VS 1-2 VS 1-2 SI 1-2 I 1-3

Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included

INTERNATIONAL GEMOLOGICAL INSTITUTE

IGI



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EMERALD CUT

3.04 CARATS

D

9.53 X 6.92 X 4.53 MM

Color Grade

D

Clarity Grade

VS 1

Depth

65.5%

Table

65%

Girdle

Slightly Thick

Culet

Long

Polish

EXCELLENT


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